

Introduction

The M-PGHFWMWAF wafer pincer grip is suitable for use with various wafer sizes from 100 - 150mm diameter.

Adds 62.6mm to dimension Y of the main product.

Description	Part Code
Straight pincer high force version for wafer	M-PGHFWMWAF

Specifications:

Materials

Stainless steel 1.4301

Berylco 25

Viton®

Vacuum Range

atm to 1×10^{-11} mbar

Bakeout Temperature *

150°C max.

Wafer Sizes

150mm (6"), 125mm (5"), 100mm (4")

